Submonolayer epitaxy with impurities: Kinetic Monte Carlo simulations and rate-equation analysis

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The effect of impurities on epitaxial growth in the submonolayer regime is studied using kinetic Monte Carlo simulations of a two-species solid-on-solid growth model. Both species are mobile, and attractive interactions among adatoms and between adatoms and impurities are incorporated. Impurities can be codeposited with the growing material or predeposited prior to growth. The activated exchange of impurities and adatoms is identified as the key kinetic process in the formation of a growth morphology in which the impurities decorate the island edges. The dependence of the island density on flux and coverage is studied in detail. The impurities strongly increase the island density without appreciably changing its power-law dependence on flux, apart from a saturation of the flux dependence at high fluxes and low coverages. A simple analytic theory taking into account only the dependence of the adatom diffusion constant on impurity coverage is shown to provide a semiquantitative agreement with many features observed in the simulations.

I. INTRODUCTION

Recent progress in the fabrication of atomically smooth interfaces by molecular-beam epitaxy has led to an increasing appreciation of the dramatic, detrimental, or beneficial effects that small amounts of impurities may have on the morphology of growing films. Adsorbates acting as surfactants can stabilize layer-by-layer growth of metal¹⁻⁶ and semiconductor^{7,8} surfaces. On the other hand, for the simple case of Pt(111) homoepitaxy, it was recently shown⁹ that minute coverages of CO strongly increase the step-edge barriers for interlayer transport, thus enhancing three-dimensional mound growth.¹⁰ The effect of additional surface species on growth and nucleation is also of obvious importance in more complex, technologically relevant deposition techniques such as chemical vapor deposition.¹¹ In either case the detailed atomistic kinetics and energetics of the interaction between adsorbate and deposited material influence the growth mode to a degree which makes it very difficult to formulate general rules for large classes of growth systems.

As a first step toward an improved understanding of the *generic* effects of impurities on epitaxial growth, in the present paper we introduce a minimal model which, we hope, is simple enough to extract some insights of fairly general validity, and yet possesses sufficient flexibility to include most physically relevant microscopic features. The model is based on the standard solid-on-solid description of the growth of a simple cubic crystal.^{12,13} The impurities are represented by a second particle species, which can be codeposited with the growing material or predeposited prior to growth. Impurities diffuse and interact attractively with the deposit atoms (adatoms), but they do not attract each other

and hence do not nucleate islands. The details of the model are described in Sec. II. A brief account of some preliminary results was given in an earlier communication.¹⁴

Despite its simplicity, the model contains a large number of parameters: impurity and growth fluxes, substrate temperature, and energy barriers for half a dozen kinetic processes. To focus our efforts, we concentrate on modeling a situation in which the impurities *decorate* the island edges, forming a monatomic chain along the island perimeter. Preferential adsorption of impurities at step edges is suggested by bond-counting arguments, and has often been invoked to explain the strong effect of submonolayer adsorbate coverages on growth behavior, e.g., through a change of the barrier for interlayer transport.^{1,9,15}

It will be shown in Sec. III that the growth of decorated islands requires, in addition to a suitable choice of binding energies, the possibility of impurity-adatom exchange. Such a process, which is a two-dimensional analog of the exchange mechanism responsible for the floating of surfactants in multilayer growth,⁶ was recently demonstrated to play a crucial role in the submonolayer homoepitaxy of Si(001) in the presence of hydrogen.¹⁶

In Sec. IV the influence of the adsorbates on the island density is investigated, both for codeposited and predeposited impurities. In the absence of impurities the scaling relation

$$N \sim (F/D)^{\chi} \tag{1}$$

between island density *N*, deposition flux *F*, and adatom diffusion coefficient *D* has been well established theoretically, $^{17-19}$ numerically, $^{19-23}$ and experimentally.²⁴ In two dimensions, rate-equation analysis¹⁷⁻²¹ yields the expression

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$$\chi = \frac{i^*}{i^* + 2} \tag{2}$$

for the exponent χ in terms of the size i^* of the largest unstable cluster.

There are several conceivable mechanisms by which attractive impurities²⁵ could alter relationship (1). First, impurities may act as nucleation centers, thus effectively *decreasing i** and therefore χ ; in the extreme case of immobile adatom traps, the limit of spontaneous nucleation with *i** $=\chi=0$ would be realized.^{23,26} Second, impurities decorating the island edges may induce energy barriers to attachment. Kandel²⁷ showed that, provided these barriers are sufficiently strong, the exponent χ in Eq. (1) is *increased* such that Eq. (2) is replaced by $\chi=2i^*/(i^*+3)$. Both mechanisms imply an increase of the island density compared to the case of pure homoepitaxy. Third, impurities could facilitate the breaking of small clusters, thus effectively increasing the criticalnucleus size and decreasing the island density.^{28,29}

Our simulations indicate that none of these three mechanisms are operative under the conditions used in our model: The addition of impurities is found to increase the island density in all cases, but the scaling of N with the flux F remains unaffected within the accuracy of the simulation. An analysis of the relevant microscopic processes¹⁴ reveals that, within our model, even completely decorated island edges do not provide efficient barriers to attachment, and therefore the scenario of Kandel²⁷ does not apply.

In view of Eq. (1), an increase of the island density at fixed χ suggests that the main effect of the impurities is to reduce the mobility D of adatoms. The reduction of the adatom mobility has been identified as the most important mechanism contributing to the surfactant action of Sb on Ag.^{3,4,30} Decreasing D reduces the island size and favors the growth of ramified, rather than compact, islands. Both effects enhance interlayer transport, since the adatoms landing in the second layer have more opportunities to descend, and thus promote layer-by-layer growth. In our model the island size decreases, but the island shapes remain compact, because the edge decoration facilitates edge diffusion (see Sec. III).

For an analytic description of the relation between impurity coverage, adatom mobility and island density, in Sec. V we develop a simple rate-equation approach which provides a semiquantitative explanation for many (though not all) features observed in the simulations. Some conclusions and open questions are formulated in Sec. VI.

II. MODEL

The growth model employed in this work was briefly described in an earlier paper.¹⁴ It is a solid-on-solid model with two surface species *A* and *B*, where *A* particles correspond to the growing material, and *B* particles represent the impurities. The simulation starts on a flat substrate composed only of *A* atoms. The basic microscopic processes are deposition and migration; desorption is not allowed. Two deposition modes are considered: (i) simultaneous deposition (*codeposition*) of both species, and (ii) a *predeposition* of a certain impurity coverage prior to growth. In the case of codeposition the fluxes F_A and F_B of the two species may differ.

The migration of a surface atom is modeled as a

nearest-neighbor hopping process with the rate $R_D = k_0 \exp(-E_D/k_BT)$, where $k_0 = 10^{13}$ Hz is an adatom vibration frequency, E_D is the hopping barrier, T is the substrate temperature, and k_B is Boltzmann's constant. The hopping barrier is the sum of a term from the substrate E_{sub} and a contribution from each lateral nearest neighbor E_n . Both contributions depend on the local composition: For each term we have the four possibilities AA, AB, BA, and BB. The hopping barrier of an atom X (of type A or B) is then³¹

$$E_D^X = \sum_{Y=A,B} (n_0^Y E_{sub}^{XY} + n_1^{XY} E_n^{XY}), \qquad (3)$$

where E_{sub}^{XY} is the hopping barrier for a free X adatom on a substrate atom Y, n_0^Y is equal to 1 if a substrate atom is of type Y, and is zero otherwise; n_1^{XY} is the number of nearest-neighbor X-Y pairs; and E_n^{XY} is the corresponding contribution to the barrier (symmetric in X and Y). Lateral interactions between impurity atoms are neglected ($E_n^{BB} = 0$).

In the simulations reported in this paper we used $E_{sub}^{AA} = 0.8 \text{ eV}$, $E_{sub}^{AB} = 0.1 \text{ eV}$, $E_{sub}^{BA} = 1.0 \text{ eV}$, and $E_{sub}^{BB} = 0.1 \text{ eV}$, and the substrate temperature T = 500 K. The low values of E_{sub}^{AB} and E_{sub}^{BB} ensure that atoms deposited on top of an impurity instantaneously descend to the substrate. Growth and impurity fluxes were varied in the interval ranging from 0.00025 ML/s to 0.25 ML/s. The system sizes ranged from 300 $\times 300$ to 500×500 . The nearest-neighbor coupling E_n^{AA} between A atoms controls²² the size of the critical nucleus i^* . It may be stronger ($E_n^{AA} > E_n^{AB}$) or weaker ($E_n^{AA} < E_n^{AB}$) than the coupling to the impurities. In equilibrium at low temperatures, the former case leads to the formation of islands composed inside mainly of A atoms, with B atoms bounded near the edges, while in the latter case it is energetically more favorable when B atoms are inside the islands.

However, our simulations show that growth leads to intermixing of A and B atoms in both cases, $E_n^{AA} > E_n^{AB}$ and $E_n^{AA} < E_n^{AB}$. Thus the energetic bias favoring segregation is not sufficient to obtain configurations with impurities mostly at island edges (decorated islands). To achieve this, we have to introduce an additional thermally activated process, which allows an A atom approaching an island to exchange with an impurity covering the island edge. A similar process was introduced previously¹⁶ in the context of homoepitaxy on Si(001) with predeposited hydrogen. In that work, an A atom was allowed to exchange with an impurity provided the A atom was not bonded to another A atom at a nearest-neighbor site. In our case this modification turned out not to be sufficient, since impurities were still found to be progressively trapped inside islands during growth. We therefore also allow the exchange of an A atom with an impurity when it has a *single* bond to another A atom in a nearest-neighbor position. Using this rule, which is analogous to the exchange process invoked in the case of three-dimensional growth with surfactants,^{8,32} we obtain well-decorated islands with impurities floating on the island edges during growth [Figs. 1(b) and 1(c); see Sec. III.

In principle, the rate of the exchange process could depend on the number of nearest-neighbor bonds (0 or 1) of the *A* atom. We observed that the difference of both rates is not crucial provided both processes are active. The rates of these



FIG. 1. Examples of configurations for the total coverage θ = 0.2 ML obtained by simultaneous deposition with flux $F_A = F_B$ = 0.004 ML/s, $E_n^{AA} = 0.3$ eV, and different energy barriers E_n^{AB} and E_{ex} : (a) $E_n^{AB} = 0.1$ eV, $E_{ex} = 1$ eV; (b) $E_n^{AB} = 0.2$ eV, $E_{ex} = 1$ eV; (c) $E_n^{AB} = 0.4$ eV, $E_{ex} = 1$ eV; and (d) $E_n^{AB} = 0.2$ eV, $E_{ex} = 2$ eV. We show only 50×50 sections of larger simulation boxes.

processes are taken as $k_{ex} = k_0 \exp(-E_{ex}/k_BT)$, where E_{ex} are the corresponding activation barriers. For both processes there is a maximum activation barrier above which the decorated geometry is not observed. In the following, the barriers for both types of exchange are for simplicity set to be equal.

III. ISLAND MORPHOLOGY

In Fig. 1 we show examples of typical configurations with the same partial coverage of both species $\theta_A = \theta_B = 0.1$ ML (i.e., the total coverage $\theta = \theta_A + \theta_B = 0.2$ ML) obtained by codeposition of adatoms and impurities with fluxes $F_A = F_B$ = 0.004 ML/s. Figures 1(a), 1(b), and 1(c) illustrate the effect of varying the relation between E_n^{AA} and E_n^{AB} for E_n^{AA} = 0.3 eV. Several features can be identified. First, the island density increases with E_n^{AB} . This can be explained by the observation [cf. Fig. 1(c) for $E_n^{AB} = 0.4 \text{ eV}$] that, for larger E_n^{AB} , free A atoms start to be captured by impurities, and many small islands containing impurities and a few A atoms appear on the surface in addition to already existing decorated islands. These small islands act as nucleation centers that lead to an increase of the island density. For large E_n^{AB} , almost all impurities will capture an A adatom for a certain time. As we argue in Sec. V, this effect causes a reduction of adatom mobility by the impurities.

Whereas the island density increases, the density of free impurities decreases with increasing E_n^{AB} due to (i) the stronger *A*-*B* bond favoring the binding of impurities at island edges, and (ii) the increase of the island density that leads to

smaller islands with more perimeter sites. (Note that we do not obtain decorated islands for simultaneous deposition at very large fluxes or at very early stages of growth, since there are not enough impurities available to cover all perimeter sites.)

The degree of edge decoration also strongly depends on the value of E_n^{AB} . Edge decoration is not observed for small $E_n^{AB} = 0.1$ eV, it is only partial for $E_n^{AB} = 0.2$ eV, and it becomes perfect for $E_n^{AB} = 0.4$ eV (cf. Fig. 1). Hence, in order to obtain decorated islands, the barrier E_n^{AB} has to be larger than a minimal value. A simple detailed balance argument¹⁴ shows that the fraction f_0 of uncovered edge sites is given by

$$f_0 = (1 + \theta_B e^{E_n^{AB}/k_B T})^{-1}, \qquad (4)$$

and thus at T = 500 K a barrier of $E_n^{AB} \ge 0.2$ eV is required. As we shall see in Sec. V, the condition $f_0 \ll 1$ also implies that the diffusion of A atoms is slowed down considerably by the impurities.

Another important parameter determining decoration of island edges is the exchange barrier $E_{\rm ex}$ that was in our simulations varied from 0.8 to 2 eV. For a small value of $E_{\rm ex}$, impurities are driven toward island edges, whereas for large $E_{\rm ex}$, the exchange process is not active and impurities are often incorporated inside the islands. The impurities were observed to be floating on the island edges for small $E_{\rm ex}$, both for $E_n^{AA} > E_n^{AB}$ [Fig. 1(b)] and for $E_n^{AA} < E_n^{AB}$ [Fig. 1(c)]. Figure 1(d) shows a configuration for $E_{\rm ex} = 2$ eV in the case $E_n^{AA} > E_n^{AB}$. The surface morphology is similar to the one observed for $E_n^{AA} < E_n^{AB}$ (not shown), where quite a regular checkerboard structure is produced with almost no free impurities on the surface. Thus in order to obtain decorated islands, $E_{\rm ex}$ has to be lower than a threshold value which in the present case is about 1.2 eV.

A further remarkable feature of the configurations displayed in Figs. 1(b) and 1(c) is that the compact square island shape is maintained as the island density increases. In fact, careful inspection shows that the kink density on the well decorated edges is *smaller* than when the decoration is incomplete. This reflects the *enhancement of edge diffusion* by the impurities: The energy barrier for an adatom moving along the decorated step edge within the impurity layer is E_{ex} which, under the conditions of Figs. 1(b) and 1(c), is smaller than both the barrier $E_{sub}^{AA} + E_n^{AA}$ for diffusion along an uncovered step and the barrier $E_{sub}^{AA} + E_n^{AB}$ for edge diffusion on the outside of the impurity layer. Clearly this is true only if the exchange of singly bonded A atoms is allowed, which underlines the importance of this type of exchange process.

IV. ISLAND DENSITY SCALING

A. Simultaneous growth

In Sec. III, we qualitatively described the growth morphology for one fixed value of the deposition flux. Here we present results for the behavior of the island density N as a function of flux F and coverage θ , and discuss its dependence on the kinetic parameters. Results for each set of parameters were obtained by averaging over several independent simulation runs.



FIG. 2. Averaged island density as a function of flux F_A for several values of the total coverage $\theta = \theta_A + \theta_B$ and different energy barriers: $E_n^{AB} = 0.2 \text{ eV}$, open symbols; $E_n^{AB} = 0.4 \text{ eV}$, filled symbols. The adatom interaction energy $E_n^{AA} = 0.3 \text{ eV}$ and the exchange barrier $E_{\text{ex}} = 1 \text{ eV}$ are fixed, and the impurity flux $F_B = F_A$. The behavior in the absence of impurities (homoepitaxy, $F_B = 0$) is shown for comparison. Inset: The effect of the exchange barrier E_{ex} on the island density at a coverage $\theta = 0.2 \text{ ML}$. Circles represent the data from the main figure for $E_{\text{ex}} = 1 \text{ eV}$, and squares the corresponding data for $E_{\text{ex}} = 1.2 \text{ eV}$.

In the presence of impurities, islands are composed of both A and B atoms. The definition of the island size becomes ambiguous. We can either define the size of an island as the number of A atoms in a connected cluster of A atoms forming the island, or measure the island size counting the total number of atoms of both types. Here we use the former possibility, which is appropriate for growth with impurities segregating on the edges of the islands, and allows a direct comparison with growth without impurities. However, visual inspection of configurations showed that, for $E_{ex} > 1.2$, there exist islands containing several mutually disconnected clusters of A atoms. Hence our definition cannot be applied straightforwardly for large E_{ex} . In the following, we restrict ourselves to situations where the intermixing inside the islands is negligible. Simulations for larger values of E_{ex} indicate that the flux dependence of the island density flattens [the exponent χ in Eq. (1) decreases], but due to the ambiguity in the definition of the island density in presence of intermixing, we did not attempt to assess the physical significance of this observation.

1. Flux dependence

Figure 2 shows the island density N as a function of the adatom flux F_A for several coverages θ and different energy barriers E_n^{AB} and E_{ex} (inset). The energy barrier $E_n^{AA} = 0.3$ eV is fixed, and the impurities and adatoms are codeposited with the same flux $F_B = F_A$. For comparison we also show data for homoepitaxial growth without impurities at two coverages $\theta = 0.05$ and 0.1 ML. We can see that for $E_n^{AB} = 0.2$ eV and $E_{ex} = 1$ eV, the island density is quite close to the corresponding value in homoepitaxy. With increasing interaction energy between adatoms and impurities, the island density



FIG. 3. Dependence of the island density on the flux F_A at constant $F_B = 0.016$ ML/s (open squares), compared with the situation $F_B = F_A$ (open diamonds), and with homoepitaxy (pluses), $E_n^{AB} = 0.2$ eV. Inset: The flux dependence at two constant ratios of fluxes $F_B/F_A = 2$ (filled squares) and $F_B/F_A = 1$ (filled triangles). $E_n^{AB} = 0.4$ eV compared with homoepitaxy (pluses).

dramatically increases, but the exponent χ in the power law relation (1) between flux and the island density remains nearly unchanged. For example, we find $\chi \approx 0.54$ for $E_n^{AB} = 0.2$, $\chi \approx 0.45$ for $E_n^{AB} = 0.4$, and $\chi \approx 0.54$ for homoepitaxial growth, which means that the effective critical nucleus size is $i^* \approx 2$ in this range of parameters. According to Kandel's rate-equation theory,²⁷ the scaling exponent should then become $\chi \approx 0.8$ in the presence of strong barriers to attachment. In our model this is not observed, because the bonding of the adatoms to the impurity-covered edges keeps them near the edge long enough for an exchange to occur.^{14,33}

The inset of Fig. 2 shows that the island density is further increased if the exchange barrier $E_{\rm ex}$ is set to a larger value $E_{\rm ex} = 1.2$ eV. The data for $E_{\rm ex} = 1.2$ eV and $E_n^{AB} = 0.4$ indicate a slight decrease of the exponent χ .

Figure 3 shows results obtained by varying the ratio F_B/F_A of impurity to adatom flux. In one set of simulations, using $E_n^{AB} = 0.2$ eV, the impurity flux was kept constant at $F_B = 0.016$ ML/s, while the adatom flux F_A was varied. For large fluxes $F_A > F_B$, the island density is seen to approach the data obtained for homoepitaxy, indicating that the impurities have no effect, while for small fluxes $F_A < F_B$ the flux dependence is described by an effective power law $N \sim F_A^{\chi'}$ with $\chi' \approx 0.36 < \chi$. An interpretation of this behavior will be given at the end of Sec. V B 2.

In the second set of simulations shown in Fig. 3, which were carried out using $E_n^{AB} = 0.4$ eV, both fluxes were varied keeping the ratio $F_B/F_A = 2$ constant. This is seen to further increase the island density without changing the flux dependence. In this sense, an increase in the coverage of impurities (by increasing F_B) is equivalent to increasing their effective-ness through an increase of the bond energy E_n^{AB} . A quantitative formulation of this statement will be given in Sec. V.

2. Coverage dependence

A noteworthy feature in comparison with homoepitaxy is a stronger coverage dependence of the island density. This is



FIG. 4. Density of islands (solid lines) and free adatoms (dashed lines) as a function of coverage θ_A for homoepitaxy (no symbols) and for two different energy barriers $E_n^{AB} = 0.2$ eV (diamonds) and $E_n^{AB} = 0.4$ eV (circles). Adatoms and impurities are codeposited at the same flux, $F_A = F_B = 0.004$ ML/s.

seen in Fig. 2 for both weak $(E_n^{AB} = 0.2 \text{ eV})$ and strong $(E_n^{AB} = 0.4 \text{ eV})$ interactions with impurities, but it is more pronounced for strong interaction, in particular at larger fluxes. We followed the coverage dependence in more detail for a fixed flux, and in addition to the island density we also measured the density of free adatoms n. The results obtained at a medium flux $F_A = 0.004$ ML/s are compared with homoepitaxy in Fig. 4. Both in impure growth and in homoepitaxy the island density shows an initial regime of rapid increase followed by a "saturation" regime in which it increases much more slowly with coverage. However, the residual coverage dependence in the saturation regime is stronger in the presence of impurities, and furthermore the onset of the saturation regime is delayed as the interaction between adatoms and impurities increases. A quantitative description of this effect will be provided in Sec. V B 2.

The density of adatoms exhibits a completely different behavior as compared to homoepitaxy. We observe that for growth with impurities, the adatom density is comparable to the island density up to the coverage $\theta_A = 0.1$ ML, whereas in homoepitaxy the adatom density rapidly decreases after reaching a maximum at the beginning of the saturation regime (cf. Sec. V A). Other surprising features are the power-law increase $n \sim \theta_A^{0.75}$ observed over almost two decades in the case of strongly interacting impurities, and the weak oscillations of the adatom density for coverages $\theta_A > 0.01$ (cf. Fig. 4). We will return to the behavior of the adatom density in Sec. V B 2.

3. Next-nearest-neighbor interaction

A modification of the model in which the barrier for diffusion E_B^X contains an additional contribution from each lateral next-nearest neighbor of the opposite type was also studied. This implies that a term $n_2^{AB}E_{nn}^{AB}$ is added to the right hand side of Eq. (3). Here n_2^{AB} is the number of next-nearest neighbors of the type opposite to the atom under consideration, and E_{nn}^{AB} is the corresponding contribution to the acti-



FIG. 5. Examples of configurations for the total coverage θ = 0.2 ML obtained by simultaneous deposition with fluxes $F_A = F_B = 0.004$ ML/s, $E_n^{AA} = 0.3$ eV, and $E_{ex} = 1$ eV in a modified model with next-nearest-neighbor interaction: (a) $E_n^{AB} = E_{nn}^{AB} = 0.1$ eV and (b) $E_n^{AB} = E_{nn}^{AB} = 0.4$ eV. We show only 50×50 sections of larger simulation boxes.

vation barrier. We do not consider next-nearest-neighbor contributions from pairs of particles of the same type. For simplicity, the new parameter E_{nn}^{AB} is set equal to E_n^{AB} .

Our motivation for introducing the additional term is a desire to study an improvement in the decoration of island edges by impurities, and the resulting decrease of the fraction f_0 of uncovered edge sites. The additional interaction also enhances the probability of nucleation around impurities because the number of sites at which an adatom can be captured is considerably higher. The configuration shown in Fig. 5(a) demonstrates that now we obtain almost perfect decoration also for $E_{n}^{AB} = E_{nn}^{AB} = 0.1$ eV. Figure 5(b) illustrates the nucleation of small islands.

nucleation of small islands. For $E_n^{AB} = E_{nn}^{AB} = 0.1$ eV, the island density is nearly the same as for homoepitaxy for all fluxes studied, and decoration is perfect provided there is sufficient amount of impurities available. This shows that in the presence of nextnearest-neighbor interactions the decorated edges are also unable to block the attachment of adatoms efficiently. For larger values of $E_n^{AB} = E_{nn}^{AB}$, the additional interaction causes an increase of the island density and a *decrease* of the scaling exponent χ . For example, the effective value for E_n^{AB} $= E_{nn}^{AB} = 0.2$ eV is $\chi \approx 0.42$, and for $E_n^{AB} = E_{nn}^{AB} = 0.4$ eV it drops to $\chi \approx 0.3$. This suggests that the nucleation of small islands described above effectively lowers the size i^* of the critical nucleus.

B. Predeposition of impurities

We performed simulations with predeposition of impurities for the same set of parameters as for codeposition. In order to obtain a morphology with island edges decorated by impurities, we need an appropriate value of E_{ex} . Complete decoration also requires a sufficient amount of impurities available on the surface. The data presented are for a predeposited coverage $\theta_B = 0.1$ ML. Examples of morphologies for $E_n^{AB} = 0.2$ eV and $E_n^{AB} = 0.4$ eV are shown in Fig. 6, and look qualitatively similar to Figs. 1(b) and 1(c).

The F_A dependence of the island density is compared with the results for codeposition in Fig. 7. The island densities in the predeposition regime are slightly higher than for



FIG. 6. Examples of configurations deposited with flux $F_A = 0.004$ ML/s at a coverage $\theta_A = 0.1$ ML after predeposition of $\theta_B = 0.1$, using parameters $E_n^{AA} = 0.3$ eV, $E_{ex} = 1$ eV, (a) $E_n^{AB} = E_{nn}^{AB} = 0.2$ eV, and (b) $E_n^{AB} = E_{nn}^{AB} = 0.4$ eV. We show only 50×50 sections of larger simulation boxes.

codeposition. This is qualitatively plausible, since the predeposited impurities are present on the surface throughout the deposition process, and hence their effect on growth accumulates over time. The corresponding curves are shifted by a factor independent of the flux. The slope remains the same as for codeposition. The difference from codeposition is that there is no appreciable coverage dependence for θ_A larger than 0.05 ML, except at larger fluxes in the case of strongly interacting impurities.

The detailed coverage dependence for a fixed flux is shown in Fig. 8. We see that the behavior of both the island density and the adatom density is qualitatively similar to homoepitaxy. The island density saturates, and at the same time the adatom density starts to decrease. The impurities only cause a shift of the crossover to the saturation regime to a higher coverage, the shift being larger for stronger interaction between adatoms and impurities. We shall return to this effect in Sec. V B 1.



FIG. 7. Comparison of averaged island densities as a function of flux F_A for codeposition (circles) and predeposition (triangles), for different energy barriers: $E_n^{AB} = 0.2$ eV, open symbols; $E_n^{AB} = 0.4$ eV, filled symbols. The predeposited coverage is $\theta_B = 0.1$ ML. The adatom interaction energy $E_n^{AA} = 0.3$ eV and the exchange barrier $E_{ex} = 1$ eV are fixed. The behavior for homoepitaxy is shown for comparison.



FIG. 8. Densities of islands (solid lines) and free adatoms (dashed lines) as a function of coverage θ_A for homoepitaxy (no symbols), and for predeposition with two different energy barriers $E_n^{AB} = 0.2 \text{ eV}$ (diamonds) and $E_n^{AB} = 0.4 \text{ eV}$ (circles). The flux of the adatoms is $F_A = 0.004$ ML/s, and the predeposited coverage of impurities is $\theta_B = 0.1$ ML.

V. RATE-EQUATION THEORY

In this section, we develop a simple rate-equation approach to explain, at least qualitatively, the main impurity effects on the island density which were presented in Sec. IV. Our basic assumption is that the impurities affect the growth process *only by slowing down the diffusion of ada-toms*. To obtain a simple analytic expression for the effective adatom diffusion coefficient $\overline{D}(\theta_B)$ in the presence of an impurity coverage θ_B , we further replace the (mobile) impurities by static traps with binding energy E_n^{AB} . Then standard results for diffusion in random media yield³⁴

$$\bar{D}(\theta_B) = \frac{D}{1 - \theta_B + \theta_B e^{E_n^{AB}/k_B T}} \equiv \frac{D}{1 + \theta_B \phi},$$
(5)

where $D = k_0 e^{-E_{sub}^{AA}/k_BT}$ is the diffusion coefficient of a single adatom on the clean substrate, and the abbreviation

$$\phi = e^{E_n^{AB}/k_B T} - 1 \tag{6}$$

has been introduced.

The first conclusion that can be drawn from Eq. (5) is that predeposited impurities, $\theta_B = \text{const}$, significantly affect the adatom diffusion only if $\theta_B \ge 1/\phi$. In the case of codeposition, $\theta_B = F_B t$, and \overline{D} becomes time or coverage dependent. It is then useful to rewrite Eq. (5) in terms of the coverage θ_A of A atoms as

$$\bar{D} = \frac{D}{1 + \theta_A / \theta^*},\tag{7}$$

with the characteristic coverage

$$\theta^* = \frac{F_A}{F_B} \phi^{-1}.$$
 (8)

For coverages $\theta_A \ge \theta^*$ the impurities begin to significantly affect the adatom mobility. Expression (8) quantifies the statement made above in Sec. IV A 1 that an increase of the flux ratio F_B/F_A in codeposition is equivalent to an increase of the A-B binding energy E_n^{AB} . For $F_A = F_B$ and T = 500 K, we have $\theta^* \approx 0.01$ for $E_n^{AB} = 0.2$ eV and $\theta^* \approx 10^{-4}$ for E_n^{AB} = 0.4 eV. In the following, these two sets of parameters will be referred to as the cases of weak and strong impurities, respectively.

A. Pure growth

We proceed by combining Eq. (5) with the simplest analytic model of nucleation, consisting of two coupled rate equations for the island density *N* and the adatom density *n*. In the absence of impurities, the equations for a critical island size $i^* = 1 \text{ read}^{17,18,20}$

$$\frac{dn}{dt} = F_A - 4Dn(2n+N), \tag{9}$$

$$\frac{dN}{dt} = 4Dn^2. \tag{10}$$

The main features of the solution of Eqs. (9) and (10) with initial condition n = N = 0 can be described as follows (see the paper by Tang²⁰ for a lucid presentation): In the *early-time regime* the adatom density increases linearly by deposition, $n \approx F_A t = \theta_A$, and accordingly the island density grows as

$$N \approx (4/3) (D/F_A) \theta_A^3 \,. \tag{11}$$

In the *late-time regime* the adatoms are mainly captured by preexisting islands. This implies that $n \approx F_A / DN \ll N$ and the island density grows more slowly, as

$$N \approx (F_A/12D)^{1/3} \theta_A^{1/3},$$
 (12)

while the adatom density decreases as $n \sim \theta_A^{-1/3}$. The transition between the two regimes occurs at a coverage

$$\theta_1 \sim (F_A/D)^{1/2}.$$
 (13)

Keeping the coverage fixed while increasing the flux therefore takes the system from the late-time regime, where $N \sim F^{1/3}$, into the early-time regime with $N \sim F^{-1}$, with a maximum in the island density attained at a critical flux $F^c \sim D \theta^2$.

To generalize these estimates to the case $i^*>1$, we replace the nucleation equation (10) by^{17,18}

$$\frac{dN}{dt} \sim Dn^{i^{*}+1}.$$
(14)

Then the early-time behavior becomes $N \sim (D/F) \theta_A^{i^*+2}$, while in the late-time regime

$$N \sim (F_A/D)^{i^*/(i^*+2)} \theta_A^{1/(i^*+2)}, \qquad (15)$$

in agreement with expression (2) for the scaling exponent χ . The transition coverage θ_1 is estimated by matching the two behaviors, which yields

$$\theta_1 \sim (F_A/D)^{2/(i^*+3)}.$$
 (16)

For $i^*=1$ the coverage dependence of the densities of islands and adatoms observed in microscopic simulations is in accordance with the rate-equation theory.^{20,21} In the reversible case $i^*>1$, the simple rate equations are quantitatively inappropriate, though the key qualitative features—the existence of an early-time regime of a rapid increase of the island density, followed by a "precoalescence saturation regime" with little change in *N*—remain.²²

B. Impure growth

1. Predeposition

The effect of predeposited impurities is obtained simply by replacing D by the constant expression (5) for D in Eqs. (15) and (16). Consequently the island density in the latetime regime increases by a factor $(1 + \theta_R \phi)^{i^*/(i^*+2)}$, which is independent of flux or A coverage, and the onset of saturation is delayed by a factor $(1 + \theta_B \phi)^{2/(i^*+3)}$. This is in qualitative agreement with the coverage dependence of densities of islands and adatoms displayed in Fig. 8, which shows the same overall behavior as in the homoepitaxial case, only shifted to larger coverages and higher densities. Quantitatively, the numerically observed increase in the island density is consistent with the factor $(1 + \theta_B \phi)^{i^*/(i^*+2)}$ if the size of the critical nucleus is set to $i^* = 1$. On the other hand, if the critical nucleus size is assumed to be $i^*=2$, as suggested by the numerical value of χ , then the theory is seen to overestimate the increase in the island density and underestimate the delay of the onset of saturation.

As mentioned in Sec. V A, the island density at fixed coverage θ_A shows a maximum at a critical flux F^c , which is determined by setting the saturation coverage equal to θ_A . For predeposited impurities with $\theta_B \phi \ge 1$ this is given by

$$F_A^c \sim (D/\phi \theta_B) \,\theta_A^{(i^*+3)/2}. \tag{17}$$

Further discussion of predeposition in relation to codeposition will be provided below.

2. Codeposition

In the case of codeposition the situation is richer due to the coverage dependence of \overline{D} . First, the cases $\theta_1 < \theta^*$ and $\theta_1 > \theta^*$ have to be distinguished. In the first case the impurities only affect the late-time regime. For $\theta_A \ge \theta^*$ we can approximate Eq. (7) by $\overline{D} \approx D \theta^* / \theta_A$. Inserting this into the nucleation equation (14) and setting $n \approx F/\overline{D}N$, we obtain the expression

$$N \approx (F_A / D \theta^*)^{i^* / (i^* + 2)} (\theta_A)^{(i^* + 1) / (i^* + 2)}, \qquad (18)$$

which replaces Eq. (15) in the pure case. It can be seen that the scaling of N with flux F_A remains the same, i.e., the exponent χ is not affected. The impurities increase the island density by a factor $(\theta_A / \theta^*)^{i^*/(i^*+2)}$ which, in contrast to the case of predeposition, is coverage dependent. This is qualitatively consistent with the residual coverage dependence of the island density seen in Fig. 2, which is nearly absent in the corresponding predeposition data in Fig. 7. In quantitative



FIG. 9. Time evolution of the adatom (open symbols and the dashed line) and island (full symbols and the solid line) densities obtained from a numerical solution of the rate equations for $i^* = 1$ [Eqs. (9) and (10)] with a coverage-dependent diffusion constant [Eq. (5)]. The parameters were chosen for comparison with the simulation data in Fig. 4: fluxes $F_A = F_B = 0.004$ ML/s, $D = (k_0/4)\exp(-E_{sub}^{AA}/k_BT) \approx 2.15 \times 10^4 \text{ s}^{-1}$, $E_n^{AB} = 0.2 \text{ eV}$ (diamonds), and $E_n^{AB} = 0.4 \text{ eV}$ (circles). The agreement between the homoepitaxial island density (solid line) and the adatom density for weak impurities (open circles) is coincidental.

terms, however, the coverage dependence in Eq. (18) is much stronger than what is observed in the simulations. The dependence of Eq. (18) on θ^* shows that increasing the ratio F_B/F_A at constant F_A and θ_A will also increase the island density, in accordance with the simulation data shown in Fig. 3.

Noting that for codeposition $\theta_B = (F_B/F_A) \theta_A$ = $\theta_A/(\phi \theta^*)$, Eq. (18) can be rewritten as $N \approx (F_A \theta_B \phi/D)^{i^*/(i^*+2)} \theta_A^{1/(i^*+2)}$, which is identical to the expression for predeposition with $\theta_B \phi \gg 1$. A more careful calculation shows that the island density for predeposition exceeds that for codeposition by a constant factor $(i^* + 1)^{1/(i^*+2)}$, if systems of the same impurity coverage θ_B are compared. This is qualitatively consistent with Fig. 7, though the simulation data indicate that the factor is larger for weak impurities than for strong ones.

A surprising consequence of the rate equations with coverage-dependent diffusion is that the adatom density *increases* with coverage in the late-time regime. This follows from balancing the deposition term on the right-hand side of Eq. (9) against the island capture term $4\overline{D}Nn \approx 4D(\theta^*/\theta_A)Nn$, which yields

$$n \sim (F_A / D \theta^*)^{2/(i^*+2)} \theta_A^{1/(i^*+2)}$$
. (19)

In fact, when $\theta_1 < \theta^*$, the adatom density is a nonmonotonic function of coverage: It increases as $n \sim \theta_A$ for $\theta_A < \theta_1$, decreases as $n \sim \theta_A^{-1/(i^*+2)}$ for $\theta_1 < \theta_A < \theta^*$, and increases again according to Eq. (19) for $\theta_A > \theta^*$. This is illustrated in Fig. 9, which is reminiscent of the simulation data for the adatom density in Fig. 4. However, in contrast to the simu-



FIG. 10. Rate-equation predictions for the flux dependence of the island density in the case of codeposition with $F_A = F_B$ at a total coverage $\theta = 0.1$ ML. The parameters were chosen as in Fig. 9. For comparison with Fig. 7, data for predeposition with $\theta_B = \theta_A = 0.05$ ML/s in the case of strong impurities are shown as well.

lations, the late-time adatom density given by Eq. (19) is small compared to the island density [Eq. (18)], and neither the intermediate scaling regime $n \sim (\theta_A)^{0.75}$ nor the oscillations of *n* seen in Fig. 4 are reproduced by the rate equations.

Here and in the following figures we show results obtained by numerical integration of the rate equations (9) and (10) for $i^*=1$, with *D* replaced by \overline{D} . This is sufficient for a qualitative comparison, and relieves us of the necessity to explicitly treat the growth dynamics of the intermediate unstable clusters. On the other hand, the choice of $i^*=1$ implies that a quantitative comparison between simulations and rate-equation results should not be attempted.

Next consider the case $\theta_1 > \theta^*$. For coverages in the early-time regime which satisfy $\theta_A \ge \theta^*$, we set $\overline{D} \approx D \theta^* / \theta_A$ and obtain, using $n \approx \theta_A$, the early-time behavior $N \sim (D \theta^* / F_A) \theta_A^{i^*+1}$. The onset of the saturation regime then occurs at a coverage

$$\tilde{\theta}_1 \sim (F_A / D \,\theta^*)^{2/(i^*+1)},\tag{20}$$

which exceeds the corresponding expression (16) for the pure system by a factor $(\theta_1/\theta_*)^{2/(i^*+1)}$. Thus both predeposited and codeposited impurities delay the onset of the saturation regime.

The critical flux at which the island density attains a maximum is now given by

$$F_B^c \sim (D/\phi) \,\theta_A^{(i^*+1)/2},$$
 (21)

which is seen to become identical to the predeposition expression (17) by setting $\theta_B = (F_B/F_A) \theta_A$. A quantitative evaluation using the parameters of the simulations shows that the critical flux is beyond the range of simulated fluxes for the case of weak impurities, while it should be observable for strong impurities. This is illustrated in Fig. 10. It therefore appears natural to identify the saturation of the flux de-



FIG. 11. This figure illustrates the rate-equation prediction for codeposition with a constant impurity flux $F_B = 0.016$ ML/s (solid line), and should be compared to Fig. 3. The predictions for the case $F_A = F_B$ (dashed line) and for homoepitaxy (dotted line) are also shown. $E_n^{AB} = 0.2$ eV; other parameters were chosen as in Fig. 9. Inset: the rate equation prediction for codeposition with constant flux ratio $F_B/F_A = 2$ (long-dashed line) compared to the case $F_A = F_B$ (dashed line) and to homoepitaxy (dotted line), $E_n^{AB} = 0.4$ eV.

pendence of the island density found in the simulations (see Figs. 2 and 7) with the maximum predicted by the rate equations, although it should be emphasized that the simulations show no clear evidence of a decrease of N beyond the plateau.

Finally, we address the effect of changing the adatom flux F_A while keeping the impurity flux F_B constant. At fixed θ_A this implies a crossover from $\theta_A \ll \theta^*$ for $F_A \gg F_B \phi \theta_A$ to $\theta_A \gg \theta^*$ for $F_A \ll F_B \phi \theta_A$. In the high flux regime the island density N is unaffected by the impurities, while in the low flux regime $N \sim (F_A/D)^{\chi} (\theta_A/\theta^*)^{\chi} \sim (F_B \phi/D)^{\chi}$ becomes *independent* of F_A , since $\theta^* \sim F_A$. This is illustrated in Fig. 11, which should be compared to Fig. 3. The behavior is qualitatively similar, however instead of a plateau at low fluxes the Monte Carlo simulations show a second scaling regime $N \sim F_A^{\chi'}$ with a nonzero exponent $\chi' < \chi$.

3. Effect of edge decoration

In the formulation of the rate equations we have assumed that all deposited impurities contribute to the impurity coverage in expression (5) for the effective diffusion coefficient, thus neglecting the fact that a certain fraction of impurities is bound at the island edges. This assumption is self-consistent only if the density n_e of edge sites, as predicted by the rate equations, is small compared to the deposited coverage θ_B of impurities at all times.

For compact islands the density of edge sites is of the order of $N\sqrt{A}$, where $A \sim (\theta_A - n)/N$ is the area of an island, and hence

$$n_e \sim \sqrt{N(\theta_A - n)}.\tag{22}$$

In the saturation regime n, $N \ll \theta_A$; thus $n_e \sim \sqrt{\theta_A N}$. In the early-time regime $n \approx \theta_A$ to leading order, and the density of edge sites is determined by the next-to-leading correction. Analysis of the rate equations shows that $n_e \sim N$ both for $\theta_A < \theta^*$ and for $\theta_A > \theta^*$, which implies that the island size does not increase with coverage in this regime.

Using the estimates for n_e , the importance of the impurities bound at the edges can be worked out for specific cases. Since evidently $n_e \ll \theta_A$ always, a *sufficient* condition for the irrelevance of edge decoration is that $\theta_B > \theta_A$ at all times. This is true for predeposited impurities up to a coverage $\theta_A = \theta_B$, and for codeposition with $F_A \leq F_B$. Among the situations treated earlier in this section, the only case where corrections due to edge decoration may be expected is deposition at fixed impurity flux F_B in the transition region F_B $\leq F_A \leq F_B \phi \theta_A$ (see Fig. 11). For fluxes $F_A > F_B \phi \theta_A$ the impurities were seen to be irrelevant even if the full impurity coverage contributes to slowing down the adatoms. Since the edge decoration decreases the impurity concentration on the terraces, it is likely that its only effect will be to shift the point where the island density becomes equal to its homoepitaxial value toward smaller deposition fluxes.

VI. CONCLUSIONS

A brief glance at the results presented in this paper may lead to disappointment: No dramatic change of the exponent χ has been found, contrary to expectations in any of the modifications of the simulation model.³³ However, upon closer inspection, our work reveals several nontrivial features that should not be overlooked in the large amount of numerical data.

(i) We have established that a perfect decoration of island edges in our model requires a process of adatom exchange that is completely analogous to the exchange discussed for surfactant-mediated growth of semiconductors.³² A feature worth remembering is the *enhancement of diffusion of adatoms along island edges* via the exchange process with impurities attached to these edges. This mechanism of smoothing on a one-dimensional substrate provides another perspective and possible interpretation of the smooth growth on a two-dimensional substrate in the presence of a surfactant. Smoothing of island shapes should be experimentally verifiable and may have practical implications.

Given the fact that size and shape of islands (including the number of kinks at island edges) in the submonolayer regime of growth determine the developing surface morphology (cf. most of the experimental papers cited below, and in particular Ref. 10), a possibility to control *both* of them by adding impurities seems very attractive.

(ii) From a theoretical perspective, we have been able to obtain insight into (and even semiquantitative agreement with) the simulation results, using rather simple rate-equation theory. The surprising resistance to change of the exponent χ can be understood within this theory, as well as other features of the simulations, such as the strikingly different behavior of the adatom density during impure growth with codeposition as compared to the case of homoepitaxy.

Our research also leads to questions. One would like to understand better the details of behavior observed, in particular the oscillations of the adatom density seen in simulations (Fig. 8). Another open question concerns "monovalent" impurities that can bond to island edges but do not bond to adatoms approaching these edges, and which therefore should bring about an efficient passivation of the island boundaries. Preliminary simulations suggest that this effect alone does not bring about any significant change in the value of the exponent χ .

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